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Dad

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Mohamed N. Darwish; Frederick P. Giles; Kam Hong Lui; Kuo-In
Chen; Kyle Terrill
Assignee: Siliconix incorporated
Title: Trench MIS Device With Reduced Gate-To-Drain Capacitance
Serial No.: Not Yet Known Filing Date: HEREWITH
Examiner: Not Yet Known Group Art Unit: Not Yet Known
Docket No.: M-11671 US

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San Jose, California
August 10, 2001

BOX PATENT APPLICATION
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR § 1.97(b)

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, § 1.97 and § 1.98, Applicant wishes to call to the attention of the Examiner the documents cited in the enclosed form PTO 1449 and the following documents:

1. U.S. Patent Application No. 09/591,179 Filed 6/8/00

Copies of the documents cited on the PTO 1449 and hereinabove are enclosed.

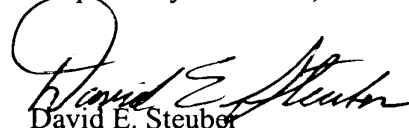
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1. an admission that the documents are necessarily prior art with respect to the instant invention;
2. a representation that a search has been made, or
3. an admission that the information cited herein is, or is considered to be, material to patentability as defined in § 1.56(b).

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Respectfully submitted,



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